

3c971 U.S. PTO
10/044500
01/10/02

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10044500	FILING DATE 01/10/2002	CLASS 361 456	SUBCLASS 285 234	GAU 2836 4733	EXAMINER HITOV
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279/128 Rik Ricket

**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2001-022294 01/30/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no		
35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no		791_182
Verified and Acknowledged Examiners's initials			
TITLE : Electrostatic chuck having bonded structure and method of manufacturing the same			

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
ISSUE FEE		Total Claims	Print Claim for O.G.
Amount Due	Date Paid	DRAWING	
Assistant Examiner		Sheets Drwg.	Figs. Drwg.
Primary Examiner		Print Fig.	
PREPARED FOR ISSUE		Application Examiner	
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